



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:  
Davis, et al.

Group Art Unit: 2812

Serial No.: 10/665,934

cos 4

Examiner: Brook Kebede

Confirmation No.: 6821

§ 3

Filed: September 19, 2003

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For: Method Of Controlling Critical Dimension Microloading Of Photoresist Trimming Process By Selective Sidewall Polymer Deposition

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Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**CERTIFICATE OF MAILING**

37 CFR 1.8

I hereby certify that this correspondence is being deposited on January 6, 2005 with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

01/06/2005

Dear Sir:

**RESPONSE TO OFFICE ACTION DATED OCTOBER 6, 2004**

In response to the Office Action dated October 6, 2004, having a shortened statutory period for response set to expire on January 6, 2005, please enter the following response and reconsider the claims pending in the application for reasons discussed below. Although applicants believe that no fee is due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/7989/LYC, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper. Remarks begin on page 5 of this paper.